

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

SHEET 1 of 1

Complete if Known

Application Number	10/813,372
Filing Date	March 30, 2004
First Named Inventor	Ming Li, et al.
Art Unit	2812
Examiner Name	Not Yet Assigned
Attorney Docket No.	MATG-395US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
RB	1	WO 01/03157 A1	01/11/2001			<input type="checkbox"/>

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
RB	1	International Search Report for App. No. PCT/US2005/010492	<input type="checkbox"/>
RB	2	G. KRAUSCH ET AL., Surface modification in the optical near field, Microelectronic Engineering, 1996, pp. 219-28, No. 32	<input type="checkbox"/>
RB	3	ANARGYROS L. PANAYOTOPOULOS, Near-field laser assisted localized crystal growth and nanodeposition, Proc. Of SPIE, 2004, pp. 676-84, Vol. 5339	<input type="checkbox"/>
			<input type="checkbox"/>

Examiner Signature	<i>Richard A. An</i>	Date Considered	07/23/06
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²See Kind Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04.

³Enter Office that issued the document, by the two-letter code (WIPO Standard St.3).

⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document.

⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible.

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The collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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**INFORMATION DISCLOSURE
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SHEET 1 of 2

Complete if Known

Application Number	To Be Assigned
Filing Date	Herewith
First Named Inventor	Ming Li et al.
Art Unit	To Be Assigned
Examiner Name	To Be Assigned
Attorney Docket No.	MATG-395US

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-			
		US-			
		US-			
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FOREIGN PATENT DOCUMENTS

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RB	1.	JP 2001-239390 A	09/04/2001	Nippon Kikyumen Lens KK; Jitsuno Takahisa	Entire Document	<input checked="" type="checkbox"/>
RB	2.	JP 2001-111200 A	04/20/2001	Matsushita Electric IND CO LTd	Entire Document	<input type="checkbox"/>
RB	3.	JP 11-16856	01/22/1999	Kanagawa Kagaku Gijutsu Akad	Entire Document	<input type="checkbox"/>
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						<input type="checkbox"/>

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SHEET 2 of 2

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
<i>AL</i>	4.	A. CHIMMALGI ET AL., Femtosecond laser aperturless near-field nanomachining of metals assisted by scanning probe microscopy, Applied Physics Letters, February 24, 2003, pp. 1146-1148, Vol. 82, No. 8.	<input type="checkbox"/>
<i>AL</i>	5.	K. LIEBERMAN ET AL., Near-field optical photomask repair with a femtosecond laser, Journal of Microscopy, May/June 1999, pp. 537-541, Vol. 194, Pt 2/3.	<input type="checkbox"/>
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Signature*Subal AL*Date
Considered*07/23/06*

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